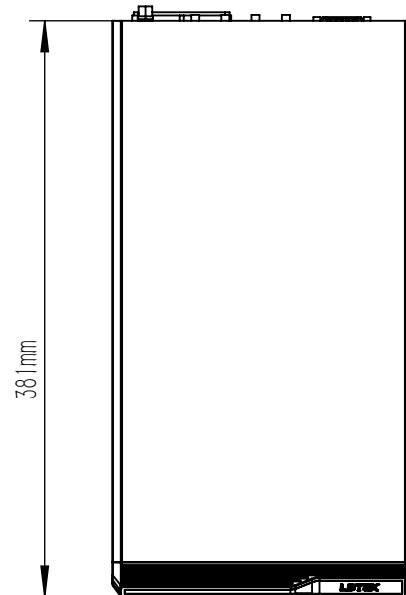
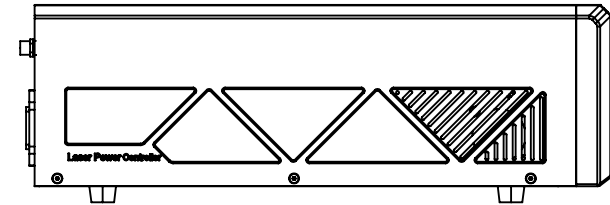
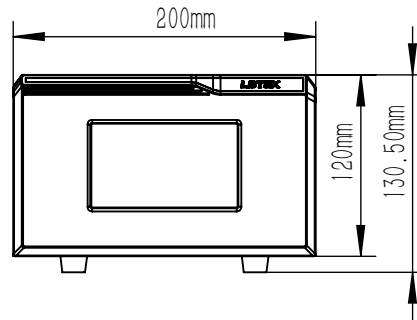
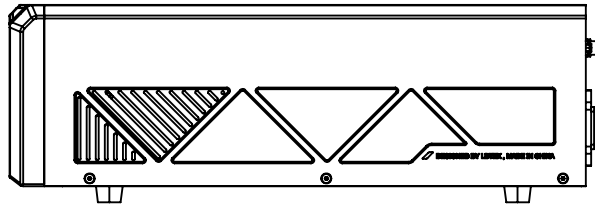
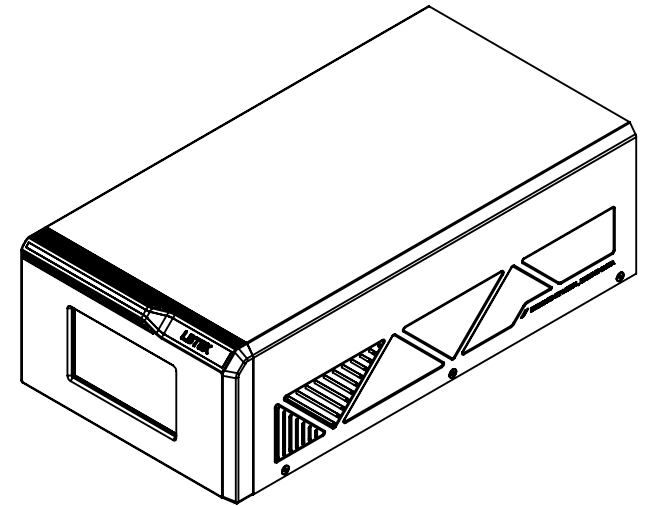
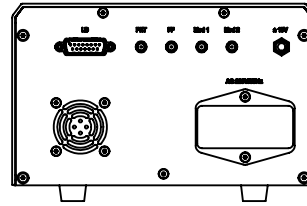




DRAWING PROJECTION			LBTEK			
	NAME	DATE				
DRAWN	PNIU	JAN./12th/26	Narrow Linewidth Semiconductor Laser Controller			
APPROVAL	ZHWANG	JAN./12th/26	MATERIAL	WEIGHT	SCALE	REV
FOR INFORMATION ONLY NOT FOR MANUFACTURING PURPOSES				g	1:5	A